

In re patent application of

Tsuyoshi SAITO, et al.

Serial No.: 09/901,577

Group Art Unit: 2132

Filed: July 11, 2001

Examiner: Derwich, Kristen M.

For: SEMICONDUCTOR MANUFACTURING APPARATUS, REMOTE  
CONTROL SYSTEM THEREOF, AND REMOTE OPERATION  
DEVICE

Commissioner for Patents  
Alexandria, Virginia 22313-1450

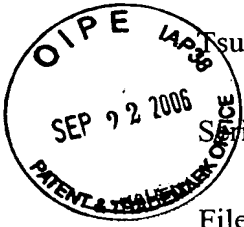
### INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicants' duty of disclosure under 37 CFR §1.56, applicants respectfully bring the following documents cited in the Japanese Office Action dated August 1, 2006, and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Copies of the listed documents are provided herewith for the convenience of the Examiner.

In compliance with the requirements of 37 CFR §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 35 U.S.C. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made, the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith. Further, an English language Abstract is attached to the reference.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicants are aware.

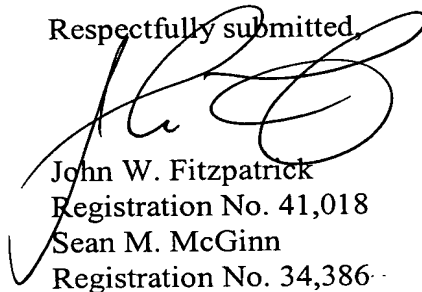


I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of that item by a foreign patent office in a counterpart foreign application, which occurred not more than three months prior to the filing of this statement.

It is respectfully requested that the listed reference be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,



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Date:

8/22/06

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FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.

KOKUSAI069

SERIAL NO.

09/901,577

## LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT

Tsuyoshi Saito et al.

FILING DATE

July 11, 2001

GROUP

2132

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO PART.		
	AG	11-122679	04/30/1999	JAPAN			ABS		
	AH	<del>10-97966</del>	<del>04/14/1998</del>	<del>JAPAN</del>	<i>previously submitted with July 11, 2002 IDS</i>			<del>ABS</del>	
	AI								
	AJ								
	AK								

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AL	Japanese Office Action dated August 1, 2006 with partial English Translation.
	AM	
	AN	

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.